



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 21, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG653410586

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

8.06 - 8.11 X 4.88 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.99 CARAT

H

VS 1

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

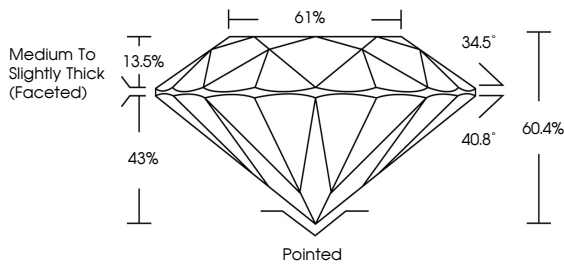
EXCELLENT

NONE

 LG653410586

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

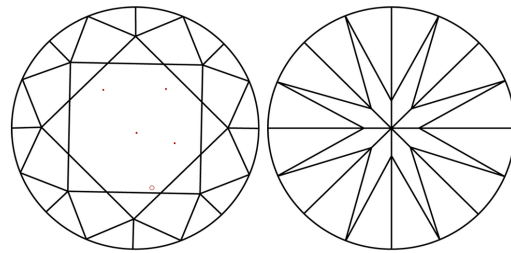
PROPORTIONS



Medium To Slightly Thick (Faceted)

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY

D E F G H I J

Faint

Very Light

Light

IF

VS ¹⁻²

VS ¹⁻²

SI ¹⁻²

I ¹⁻³

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

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ROUND BRILLIANT

8.06 - 8.11 X 4.88 MM

Carat Weight

Color Grade

Clarity Grade

Cut Grade

Depth

Table

Girdle

Medium To Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.99 CARAT

H

VS 1

EXCELLENT

60.4%

61%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

 LG653410586

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

www.igi.org

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